

Notice of References Cited	Application/Control No. 10/559,409		Applicant(s)/Patent Under Reexamination VAN DER WIJNGAART ET AL.	
	Examiner Craig Price		Art Unit 3753	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-3,667,503	06-1972	Farrell et al.	137/625.4
*	B	US-5,058,856	10-1991	Gordon et al.	251/11
*	C	US-5,065,978	11-1991	Albarda et al.	251/129.17
*	D	US-5,325,880	07-1994	Johnson et al.	137/1
*	E	US-5,445,185	08-1995	Watanabe et al.	137/596.17
*	F	US-6,279,606	08-2001	Hunnicuttt et al.	137/543.19
*	G	US-6,306,773	10-2001	Ad.ang.s et al.	438/745
*	H	US-7,320,457	01-2008	Heim et al.	251/129.06
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Hal Jerman, "Electrically-Activated, Micromachined Diaphragm Valves," Technical Digest IEEE, Sensor and Actuator Workshop, Jun. 1990, pp. 65-69.			
	V				
	W				
	X				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.